

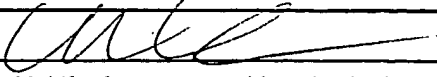
INFORMATION DISCLOSURE CITATION

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Applicant	Kiminori WATANABE et al.		
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U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
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	6,081,002	06-2000	Amerasekera et al.			
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Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
ML	J.A. Appels, et al., "High Voltage Thin Layer Devices (Resurf Devices), Philips Research Laboratories, Proc. IEDM, pp. 238-241, (1979).

Examiner		Date Considered	3/7/05
*Examiner:	Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		
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